Electronic Acknowledgement Receipt				
EFS ID:	5162904			
Application Number:	10689617			
International Application Number:				
Confirmation Number:	4799			
Title of Invention:	Method for cleaning plasma etching apparatus, method for plasma etching, and method for manufacturing semiconductor device			
First Named Inventor/Applicant Name:	Satoru Okamoto			
Customer Number:	26171			
Filer:	Roberto J. Devoto/kim bailey			
Filer Authorized By:	Roberto J. Devoto			
Attorney Docket Number:	12732-170001			
Receipt Date:	16-APR-2009			
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Time Stamp:	08:58:57			
Application Type:	Utility under 35 USC 111(a)			

Payment information:

Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$130
RAM confirmation Number	7318
Deposit Account	061050
Authorized User	

The Director of the USPTO is hereby authorized to charge indicated fees and credit any overpayment as follows:

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Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
Amendment/Req. Reconsideration-After Non-Final Reject	127320170001 reply.pdf	94564	no	9	
		be53ad2a2c5c131ed77cf1af4db91751e5d 1d163			
Warnings:	·				
Information:					
2 Fee Worksheet (PTO-06)	fee-info.pdf	30144	no	2	
		5d6d2e87e3e400f46e54a14aa3a26d87c47 bca65			
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.